



Atty. Docket No. 002187 USA/C03/PDC/WF/OR

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

David ALUMOT et al.

Application No.: 09/765,995

Group Art Unit: 2623

Confirmation No.: 1810

Examiner: Martin E. Miller

Filed: January 19, 2001

For: OPTICAL INSPECTION APPARATUS FOR SUBSTRATE DEFECT DETECTION
(As Amended)

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 2327
Arlington, VA 22202

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DEC 20 2002

Technology Center 2600

Sir:

In response to the Office Action dated August 27, 2002, the time for response having been extended to December 27, 2002 by concurrent filing of a petition and payment of extension of time fee, for which the Examiner set a three-month period for response, please amend the above-identified application as follows.

IN THE TITLE:

Please amend the title to read as follows:

OPTICAL INSPECTION APPARATUS FOR SUBSTRATE DEFECT DETECTION